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Jianda Shao
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Contents

vii *Authors*
ix *Conference Committee*

SESSION 1 THIN FILM MATERIALS I

11064 02 **Influence of transition layer on the surface scattering of unmodified silicon carbide** [11064-55]

SESSION 2 TECHNOLOGY OF THIN FILMS I

11064 03 **Thickness dependence of Cr-doped VO₂ thin films deposition by reactive pulsed magnetron sputtering** [11064-45]

SESSION 4 TECHNOLOGY OF THIN FILMS II

11064 04 **Preparation of silica thin film by hot pressing process for passive radiative cooling** [11064-22]

SESSION 5 THIN FILM MATERIALS II

11064 05 **Optical functions of fishnet metamaterial embedded in dielectrics** [11064-54]

11064 06 **Optical and electrical characteristics of radio frequency sputtered ITO and In-free transparent conductors (Invited Paper)** [11064-6]

11064 07 **Investigation on tuning of WS₂/SiC band gap with an external electric field** [11064-17]

11064 08 **Enhance anti-water ability of high transmittance film in mid-infrared band** [11064-14]

11064 09 **Performance of a spectral beam combining grating with YAG substrate** [11064-48]

SESSION 6 APPLICATION OF THIN FILMS I

11064 0A **Efficient broadband light absorption enhancement in InP/ZnO core-shell nanocone arrays for photovoltaic application** [11064-11]

SESSION 7 PHYSICS OF THIN FILMS II

- 11064 0B **Energy flow difference structure design based on micro hemisphere structure** [11064-23]
- 11064 0C **A lift-off of pattern structures on the heat-mode resists** [11064-19]
- 11064 0D **Positive and negative properties of laser heat-mode resists** [11064-33]

SESSION 8 APPLICATION OF THIN FILMS II

- 11064 0E **Wide-incident angle and low polarization aberration edge filter** [11064-24]
- 11064 0F **Subwavelength periodic nanostructures fabricated by femtosecond laser in metal, dielectric and metal-dielectric-metal coating** [11064-53]

POSTER SESSION 11064

- 11064 0G **Employing Ni-Cr co-doping to prepare low phase transition temperature VO₂ film** [11064-57]
- 11064 0H **Annealing effects on optical and structural properties of TiO₂ thin films deposited by ion beam sputtering** [11064-18]
- 11064 0I **Broadband chirped volume Bragg grating for one-hundred-femtosecond pulse compression** [11064-50]
- 11064 0J **Broadband polarization beam splitter based on subwavelength grating in Terahertz** [11064-5]
- 11064 0K **Comparison of mechanical properties evolution of polyimide films in space radiation environment** [11064-4]
- 11064 0L **Correlation between the structure and laser damage properties of ion assisted HfO₂ thin films** [11064-12]
- 11064 0M **Design and fabrication of antireflective surface microstructures on lithium triborate** [11064-51]
- 11064 0N **Design of linear polarizer in 3-13 μ m broad infrared region with multilayer nanostructures** [11064-30]
- 11064 0O **Effect of MgF₂ deposition temperature on Al mirrors in vacuum ultraviolet** [11064-42]
- 11064 0P **Effect of temperature on optical properties of CeO_x film being irradiated by Co⁶⁰ prepared by RF magnetron sputtering** [11064-8]
- 11064 0Q **Effects of different oxygen flow on refractive index and absorption characteristics of Ta₂O₅ film** [11064-37]

- 11064 OR **Efficient method for determination of laser conditions adopted in laser-induced micro-lithology based on laser polymerization size analysis** [11064-34]
- 11064 OS **Electrical property of OSR second surface mirror in space radiation environments** [11064-3]
- 11064 OT **Experimental observation and numerical analysis for dynamical output in free-running multi-longitudinal mode erbium doped fiber ring laser** [11064-15]
- 11064 OU **Green vegetables derived simultaneously carbon dots as sensitizer and carbon particles as counter electrode for dye-sensitized solar cells** [11064-26]
- 11064 OV **Improvement on fluorescent properties of photonic crystals filled by quantum dots based on multi-layer films** [11064-2]
- 11064 OW **Oblique incidence reflectance of resonators based on suspended two-dimensional membranes** [11064-40]
- 11064 OX **Optical design of perovskite/silicon laminated solar cells based on grating structure** [11064-58]
- 11064 OY **Optimization of morphology and electrochemical characteristics of nickel film by sputtering pressure** [11064-38]
- 11064 OZ **Photoelectric properties of transparent conductive metal mesh films based on crack template and its application in Perovskite solar cells** [11064-46]
- 11064 10 **Preparation and physical properties of germanium thin films** [11064-25]
- 11064 11 **Research on the time and mechanism of laser-induced air plasmas ignition** [11064-36]
- 11064 13 **Study on band gap and dispersion model of Al₂O₃ thin films with different oxygen flow rates by ion beam sputtering** [11064-32]
- 11064 14 **Study on preparation process and shielding effectiveness of graphene films** [11064-35]
- 11064 15 **Annealing effects on the optical and structural properties of Y₂O₃ thin films deposited by thermal evaporation technique** [11064-29]
- 11064 16 **Development of transparent oxide thin films for flexible devices** [11064-21]
- 11064 17 **Influence of deposition temperature and precursor pulse time on properties of SiO₂, HfO₂ monolayers deposited by PEALD** [11064-39]

Authors

Numbers in the index correspond to the last two digits of the seven-digit citation identifier (CID) article numbering system used in Proceedings of SPIE. The first five digits reflect the volume number. Base 36 numbering is employed for the last two digits and indicates the order of articles within the volume. Numbers start with 00, 01, 02, 03, 04, 05, 06, 07, 08, 09, 0A, 0B...0Z, followed by 10-1Z, 20-2Z, etc.

Bai, Yunli, 02
Cao, Hongchao, 09, 0M
Cao, Zhen, 0F
Chen, Dan, 0H, 13, 15
Chen, Fengnan, 0W
Chen, Guodong, 0C, 0D
Chen, Junming, 09
Chen, Peng, 09, 0I
Cheng, Yuyang, 0J
Dai, Huifang, 0I
Fan, Ping, 03, 0G
Fan, Xiaochun, 0B
Fu, Bo, 0P
Fu, Haiyan, 0Z
Fu, Xiuhua, 08
Gao, Enlei, 0X
Grilli, Maria Luisa, 06, 0F
Guan, Huan, 03, 0G
Guo, Meng, 10
He, Dongbing, 0I
He, Hongbo, 0F, 0M, 10
He, Qicong, 0G
He, Shikun, 0E
Hu, Guohang, 05, 0F
Huang, Lu, 0V
Huang, Ping, 0U, 0Y
Huang, Qiaolin, 0E
Huang, Ying, 0G
Huo, Tonglin, 0O
Ji, Yiqin, 0Q
Jiang, Chenghui, 0Q
Jiang, Kai, 16
Jiang, Yugang, 0H, 0Q, 13, 15
Jin, Jingcheng, 0G
Jin, Yunxia, 09, 0I, 0M
Kong, Fanyu, 09, 0I, 0M
Kong, Weijin, 0J
Kuang, Yawei, 0X
Li, Caiyu, 0J
Li, Cheng, 0R
Li, Dawei, 0R
Li, Shida, 0H, 0Q, 13, 15
Li, Shuangying, 0O
Li, Xiao, 0K
Li, Yuanjie, 16
Liu, Chen, 0Y
Liu, Dandan, 13
Liu, Dengwu, 04
Liu, Hai, 0T
Liu, Hao, 0L
Liu, Huasong, 0H, 0Q, 13, 15
Liu, Shijie, 0K
Lu, Heng, 0W
Lu, Jun, 0W
Luo, Yongping, 0U, 0Y, 0Z
Ma, Hao, 0R
Ma, Xiaofeng, 0S
Ma, Yuke, 07
Mao, Wenjing, 0W
Meng, Qingfei, 0V
Moser, Joel, 0W
Ou, Hui, 0Z
Pan, Feng, 0L
Piegari, Angela, 0F
Qin, Xuefei, 0A
Shao, Jianda, 09, 0F, 0R, 0S, 10, 17
Shao, Shuying, 10
Shao, Yuchen, 0R
Shen, Zicai, 0K, 0S
Shi, Kai, 14
Shi, Kailiang, 0B
Shi, Weimin, 0V
Song, Chen, 17
Su, Junhong, 11, 14
Sun, Wenci, 16
Sun, Yong, 0M
Sytchkova, Anna, 05, 0F
Tang, Kai, 0T
Wan, Lin, 0W
Wang, Chinhua, 0N
Wang, Fengli, 0O
Wang, Gang, 02, 0E
Wang, Guixia, 11
Wang, Hong, 16
Wang, Hui, 0P
Wang, Jie, 16
Wang, Li, 02, 0E
Wang, Linjun, 0V
Wang, Lishuan, 0H, 0Q, 13, 15
Wang, Yang, 0C, 0D
Wang, Yanzhi, 17
Wang, Yonglu, 09, 0M
Wang, Zhanshan, 0O
Wang, Zhengwei, 0C, 0D
Wei, Jingsong, 0C, 0D
Wei, Yaowei, 0L
Wu, Yonggang, 0A
Xia, Jie, 0N

Xia, Zhilin, 04, 0B
Xia, Zihuan, 0A
Xiang, Zaikui, 0P
Xiao, Pengda, 0X
Xiao, Yanping, 0T
Xiao, Zonghu, 0U, 0Z, 0Y
Xu, Jiao, 09
Xu, Nuo, 17
Xu, Shunjian, 0U, 0Y, 0Z
Xu, Xian'gang, 07
Xue, Dongbai, 15
Yan, Rongrong, 14
Yan, Ying, 0W
Yang, Chen, 0W
Yang, Xiao, 15
Yang, Yu, 0G
Yi, Kui, 10, 17
Yin, Chaoyi, 17
Yuan, Zhihao, 0N
Zeng, Tingting, 17
Zhang, Dongping, 03, 0G
Zhang, Fei, 0L
Zhang, Gong, 08
Zhang, Jiyou, 02, 0E
Zhang, Kaixin, 0F
Zhang, Kui, 0C, 0D
Zhang, Kun, 0J
Zhang, Meng, 0U
Zhang, PuHeng, 0T
Zhang, Yelan, 0J
Zhang, Yibin, 09, 0I, 0M
Zhang, Zhenfei, 04
Zhang, Zhuangzhuang, 0O
Zhang, Zongyi, 0A
Zhao, Jianle, 14
Zhao, Jingyin, 0I
Zhao, Yuan'an, 0F, 0R, 17
Zheng, Hao, 0X
Zheng, Xinyu, 0X
Zhong, Wei, 0U, 0Y, 0Z
Zhou, Hongjun, 0O
Zhou, Jian, 0A
Zhou, Xin, 14
Zhou, Yuming, 02, 0E
Zhu, Meiping, 0H, 0Q, 0S, 13, 15, 17
Zhu, Yitai, 0X
Zhu, Yubin, 0V

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- 7 Physics of Thin Films II
Chang Kwon Hwangbo, Inha University (Korea, Republic of)
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